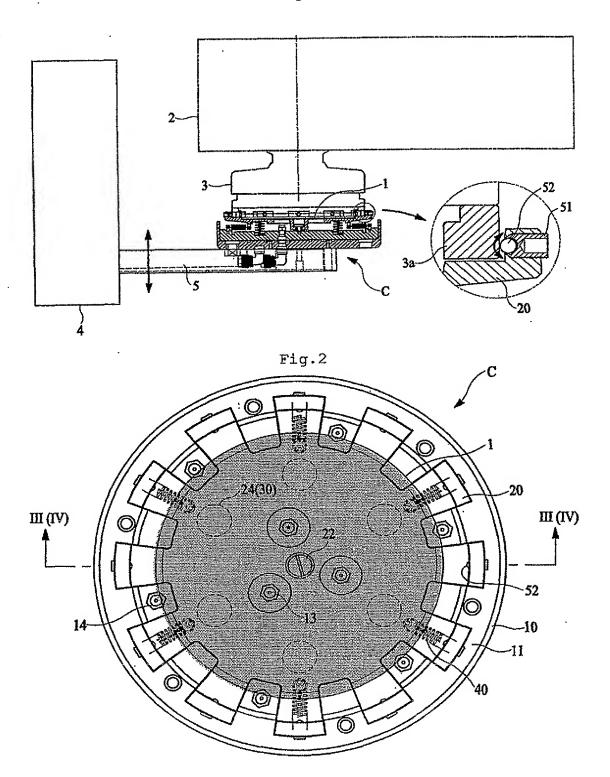
Title: LOADING DEVICE FOR CHEMICAL MECHANICAL POLISHER OF SEMICONDUCTOR WAFER
Inventors: Jung Hoon LEE
Atty Docket No.: 403835
Leydig, Voit & Mayer 202-737-6770

WO 2006/041248

PCT/KR2005/001030

1/4

Fig.1



WO 2006/041248

PCT/KR2005/001030

2/4

Fig.3

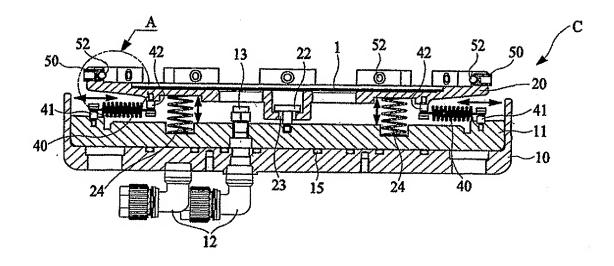
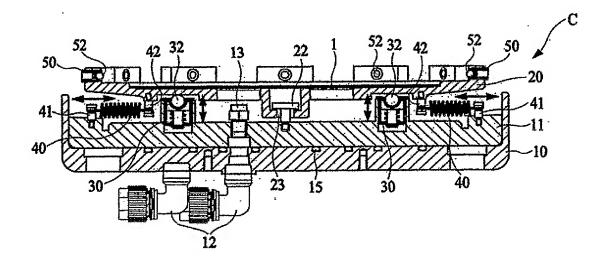


Fig.4



WO 2006/041248

PCT/KR2005/001030

3/4

Fig.5

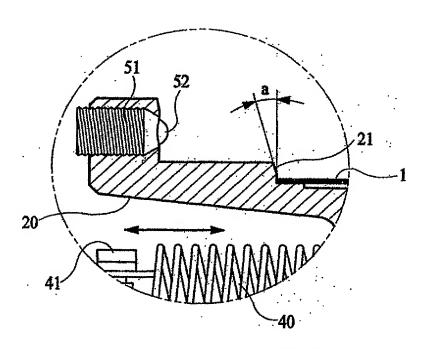
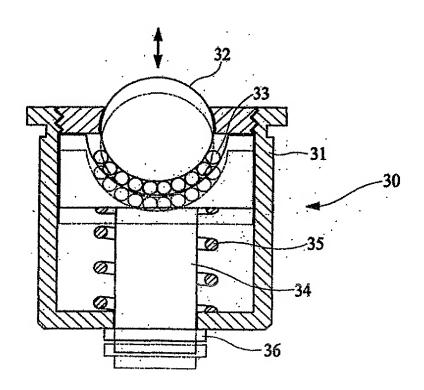


Fig.6



Title: LOADING DEVICE FOR CHEMICAL MECHANICAL POLISHER OF SEMICONDUCTOR WAFER
Inventors: Jung Hoon LEE
Atty Docket No.: 403835
Leydig, Voit & Mayer 202-737-6770

WO 2006/041248

PCT/KR2005/001030

4/4

Fig.7

